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14			jet\$4))	TBM TDB	2003/02/25 15:54
15	1	1	ultrasonic and (ink adj ejection)		2003/02/25 15:55
adj jet\$4)) (electroluminescen\$ and (ink-jet\$4 or (ink adj jet\$4)) and ultrasonic electroluminescen\$ and ((ink-jet\$4 or (ink adj jet\$4)) with thermal) (electroluminescen\$ and ((ink-jet\$4 or (ink adj jet\$4)) with thermal)) and (nozzle\$1 same heater\$1) electroluminescen\$2 and (nozzle\$1 same heater\$1) electroluminescen\$2 and (nozzle\$1 same heater\$1) electroluminescen\$2 and (nozzle same (distance or gap or space or spacing)) electroluminescen\$2 and (nozzle same (distance or gap or space or spacing)) electroluminescen\$2 and (nozzle same (distance or gap or space or spacing)) electroluminescen\$2 and (nozzle same (distance or gap or space or spacing)) electroluminescen\$2 and (nozzle same (distance or gap or space or spacing)) electroluminescen\$2 and (nozzle same (distance or gap or space or spacing)) electroluminescen\$2 and (nozzle same (distance or gap or space or spacing)) electroluminescen\$2 and (nozzle same (distance or gap or space or spacing)) electroluminescen\$2 and (nozzle same (distance or gap or space or spacing)) electroluminescen\$2 and (nozzle same (distance or gap or space or spacing)) electroluminescen\$2 and (nozzle same (distance or gap or space or spacing)) electroluminescen\$2 and (nozzle same (distance or gap or space or spacing)) electroluminescen\$2 and (nozzle same (distance or gap or space or spacing)) electroluminescen\$2 and (nozzle same (distance or gap or space or spacing)) electroluminescen\$2 and (nozzle same (distance or gap or space or spacing)) electroluminescen\$2 and (nozzle same (distance or gap or space or spacing)) electroluminescen\$2 and (nozzle same (distance or gap or space or spacing)) electroluminescen\$2 and (nozzle same (distance or gap or space or spacing)) electroluminescen\$2 and (nozzle same (distance or gap or space or spacing)) electroluminescen\$2 and (nozzle same (distance or gap or space or spacing) electroluminescen\$2 and (nozzle same (distance or gap or space or spacing) electroluminescen\$2 and (nozzle same (distance or gap or space or spacing) electroluminescen\$2 and (no	15	8	ultrasonic and (ink) and nozzie		2003/02/25 13:11
Stady Stady Stady Celectroluminescen\$ and (ink-jet\$4 or (ink adj jet\$4)) and ultrasonic electroluminescen\$ and ((ink-jet\$4 or (ink adj jet\$4)) with thermal uspar; us	-	378	electroluminescens and (ink-jets4 of (ink		
Contact or touch) Cont			adj jet\$4))	· -	2002/09/23 16:44
adj jet\$4))) and ultrasonic electroluminescen\$ and ((ink-jet\$4 or (ink adj jet\$4)) with thermal) (electroluminescen\$ and ((ink-jet\$4 or (ink adj jet\$4)) with thermal)) and (nozzle\$1 same heater\$1) electroluminescen\$2 and (nozzle\$1 same heater\$1) electroluminescen\$2 and (nozzle\$1 same heater\$1) electroluminescen\$2 and (nozzle same (distance or gap or space or spacing)) electroluminescen\$2 and (nozzle same (distance or gap or space or spacing)) electroluminescen\$2 and (nozzle same (distance or gap or space or spacing)) electroluminescen\$2 and (nozzle same (distance or gap or space or spacing) same (contact or touch)) ("4849774").PN. 843 (427/66,68).CCLS. 26 ((427/66,68).CCLS.) and (ink-jet\$4 or (ink adj jet\$4))) and thermal or 78452 78452 78452 Adj jet\$4))) and ultrasonic (ink-jet\$4 or (ink adj jet\$4))) and thermal or	-	51	(electroluminescen\$ and (ink-jet\$4 or (ink		2002,05725 10.44
- 73 electroluminescen\$ and ((ink-jet\$4 or (ink adj jet\$4)) with thermal) - (electroluminescen\$ and ((ink-jet\$4 or (ink adj jet\$4)) with thermal) - (ink adj jet\$4)) with thermal)) and (nozzle\$1 same heater\$1) - (ink adj jet\$4)) with thermal)) and (nozzle\$1 same heater\$1) - (ink adj jet\$4)) with thermal)) and (nozzle\$1 same heater\$1) - (ink adj jet\$4)) with thermal)) and (nozzle\$1 same heater\$1) - (ink adj jet\$4)) with thermal)) and (nozzle\$1 same heater\$1) - (ink adj jet\$4)) electroluminescen\$2 and (nozzle same (distance or gap or space or spacing)) uspAT; (inth adj jet\$4)) - (ink adj jet\$4)) (ink adj jet\$4)) and (ink-jet\$4 or (ink adj jet\$4)) and thermal or (ink-jet\$4 or (ink uspAT; us-pGPUB uspAT; uspAT; us-pGPUB uspAT; us-pGPUB uspAT; us-pGPUB uspAT; us-pGPUB u		Į.	adi iet\$4))) and ultrasonic		2002/09/23 10-30
adj jet\$4)) with thermal) (electroluminescen\$ and ((ink-jet\$4 or (ink adj jet\$4)) with thermal)) and (nozzle\$1 same heater\$1) electroluminescen\$2 and (nozzle\$1 same heater\$1) electroluminescen\$2 and (nozzle same (distance or gap or space or spacing)) electroluminescen\$2 and (nozzle same (distance or gap or space or spacing)) electroluminescen\$2 and (nozzle same (distance or gap or space or spacing) same (contact or touch)) ("4849774").PN. 843 (427/66,68).CCLS. ((427/66,68).CCLS.) and (ink-jet\$4 or (ink adj jet\$4)) (((427/66,68).CCLS.) and (ink-jet\$4 or (ink adj jet\$4))) and thermal or adj jet\$4)) 2002/09/23 10:26 USPAT; US-PGPUB	_	7.3	electroluminescen\$ and ((ink-jet\$4 or (ink		2002/09/23 10:30
Celectroluminescen\$ and ((ink-jet\$4 or (ink adj jet\$4)) with thermal)) and (nozzle\$1 same heater\$1)		1	adi jet\$4)) with thermal)	1 7	0000/00/03 10:36
(ink adj jet\$4)) with thermal)) and (nozzle\$1 same heater\$1) electroluminescen\$2 and (nozzle\$1 same heater\$1) electroluminescen\$2 and (nozzle same heater\$1) electroluminescen\$2 and (nozzle same (distance or gap or space or spacing)) electroluminescen\$2 and (nozzle same (distance or gap or space or spacing)) electroluminescen\$2 and (nozzle same (distance or gap or space or spacing) same (contact or touch)) ("4849774").PN. 1 (4849774").PN. 2002/09/23 10:26 USPAT; US-PGPUB	1_	6	(electroluminescen\$ and ((ink-jet\$4 or		2002/09/23 10:26
- 20	_		(ink adi jet\$4)) with thermal)) and	US-PGPUB	1
- 20 electroluminescen\$2 and (nozzle\$1 same heater\$1) - 70 electroluminescen\$2 and (nozzle same electroluminescen\$2 and (nozzle same (distance or gap or space or spacing)) - 16 electroluminescen\$2 and (nozzle same (distance or gap or space or spacing)) - (contact or touch)) - ("4849774").PN 843 (427/66,68).CCLS 26 ((427/66,68).CCLS.) and (ink-jet\$4 or (ink adj jet\$4)) - 78452 ((427/66,68).CCLS.) and (ink-jet\$4 or (ink adj jet\$4))) and thermal or	-		(nozzleśl same heaterśl)		
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- 16 electroluminescen\$2 and (nozzle same (distance or gap or space or spacing) same (contact or touch)) - 1 ("4849774").PN. - 843 (427/66,68).CCLS. 26 ((427/66,68).CCLS.) and (ink-jet\$4 or (ink adj jet\$4)) - ((427/66,68).CCLS.) and (ink-jet\$4 or (ink adj jet\$4)) and thermal or	-	70	electroluminescensz and (nozzte same		
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- 843 (427/66,68).CCLS. - 26 ((427/66,68).CCLS.) and (ink-jet\$4 or (ink adj jet\$4)) (((427/66,68).CCLS.) and (ink-jet\$4 or (ink adj jet\$4)) and thermal or - 78452 ((ink adj jet\$4))) and thermal or - 3452 ((ink adj jet\$4))) and thermal or	_	1	("4849774").PN.		2002/09/23 11.22
- 26 ((427/66,68).CCLS.) and (ink-jet\$4 or (ink adj jet\$4)) (((427/66,68).CCLS.) and (ink-jet\$4 or (ink uspat; us-pgpub uspat; us-pgpub uspat; (ink adj jet\$4))) and thermal or uspat; us-pgpub				4	2002/00/22 11:22
- 26 ((427/66,68).CCLS.) and (ink-jet\$4 or (ink uspat; us-pgpub		2/3	(427/66,68).CCLS.		\\ \\ \\ \\ \\ \\ \\ \\ \\ \\ \\ \\ \\
- 26 ((427/66,68).CCLS.) and (INK jety of US-PGPUB adj jet\$4)) - 78452 ((427/66,68).CCLS.) and (ink-jet\$4 or (ink adj jet\$4))) and thermal or US-PGPUB USPAT; US-PGPUB	_	043			1
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- 78452 adj jet\$4)) and (ink-jet\$4 or USPAT; US-PGPUB US-PGPUB	-	26	odi iot\$411	US-PGPUB	
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